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ORIGINAL ARTICLE



A novel etching technique for surface treatment of zirconia ceramics to improve adhesion of resin-based luting cements

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ABSTRACT

Objectives: Bonding of zirconia crowns and bridges to abutments is important, not only bonding of the thin resin layer to the abutment, but also bonding to the zirconia ceramic is crucial. Both mechanical and chemical adhesion are desired. Mechanical retention of dental porcelain achieved by etching with moderately concentrated hydrofluoric acid is not possible with zirconia ceramics.

The purpose of this study was to show that etching is possible with relative low melting fluoride compounds such as ammonium hydrogen difluoride and potassium hydrogen difluoride.

Materials and methods: Before melting, the fluorides can be introduced as powders or as aqueous slurries to the contact surfaces of the zirconia. After melting, the yttria-stabilized zirconia surface revealed a surface similar to an HF-etched dental feldspathic porcelain surface. Shear bond testing ($n=10$) was performed with zirconia attached to zirconia with the Duo-Link composite luting cement (Bisco) after treatment of the etched zirconia surfaces with Bis-Silane (Bisco) and the Porcelain Bonding Resin (Bisco).

Results: Values for adhesive strength (mean \pm standard deviation) after melt etching of the surfaces with initially dry powders were for K[FHF], (31.2 ± 7.5) MPa and for $\text{NH}_4[\text{FHF}]$ (31.0 ± 11.8) MPa. When initially aqueous slurries were applied, the values were for K[FHF] (42.7 ± 12.7) MPa and for $\text{NH}_4[\text{FHF}]$ (40.3 ± 10.0) MPa.

Conclusion: Good adhesion to zirconia can be achieved by a procedure including etching with selected melted fluoride compounds.

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Introduction

Due to their high strength and relative high toughness properties zirconia ceramics have been introduced in prosthetic dentistry for the production of, for example, crowns and bridges fixed to implant abutments and prepared natural teeth. Sintered yttria-stabilized tetragonal zirconia polycrystals (Y-TZP) are described as ‘polycrystalline, high-strength oxide ceramics’ without a ‘glass phase’ [1]. Compared to conventional ceramic systems such as feldspathic porcelain or glass ceramics, Y-TZP ceramics have superior mechanical properties opening broad applications in dentistry and therefore Y-TZP are increasingly used. Ceramics based on silicates like dental porcelain and glass ceramics can be etched by hydrofluoric acid (HF in water). To obtain a durable adhesion between resin and such ceramic materials the etched surface must be silanized with an organosilane. The surface structure of Y-TZP ceramics without silicon dioxide in the structure is chemically

highly inert and requires alternative techniques of surface treatments to obtain good adhesion. Similar as for silica-based ceramics, it is anticipated that Y-TZP ceramics need surface modification to obtain micromechanical retention and/or chemical bonds between the ceramic surface and the resin cement.

In several review articles, the adhesion of resin-based luting cements to zirconia has been discussed [2].

Some reported methods to enhance zirconia adhesion to resin cement are as follows: (1) surface abrasion with airborne alumina particles or roughening the zirconia surface with diamond bur to create adhesion through micromechanical retention [3,4], (2) use of tribochemical silica coating enables chemical bonds via a silane-coupling agent and the resin cement [5], (3) silica coating carried out as treatment of zirconia ceramic surfaces with plasma spraying with hexamethyldisiloxane and (4) fusing of porcelain beads to the zirconia [6], (5) etching with hydrofluoric acid by

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using long-time immersion (1–24 h) in 9.5% HF at 25 °C or for 1–30 min in 9.5% HF at 80 °C. Also immersion in 48% HF at 25 °C for 30 and 60 min has given etching [7].

A process, the so-called ‘selective infiltration etching’ (SIE) introduced to give intergranular porosities at the surface that allows resin cements to flow between the grains, resulting in interlocking [8–11]. To reduce the surface and subsurface damage by airborne particle abrasion, from now called sandblasting [12,13], a modified SIE procedure was introduced [14,15] applying relative small alumina particles (30 and 50 µm) or round 30 µm alumina particles at low pressure for sandblasting of sintered Y-TZP discs.

It has been proposed that the use of phosphate ester primers such as the monomer 10-methacryloyloxydecylidihydrogenphosphate (MDP) and phosphate-modified resin cements may form relatively stable adhesion [16].

Chemical bonding of resins to zirconia has been achieved by fluorination treatment in a plasma reactor with SF₆ gas. After contact with atmospheric humidity, the fluorinated zirconia surface becomes hydrolyzed with the formation of reactive surface hydroxyl groups, which can react with phosphate ester containing monomer of an adhesive [17]. It has also been postulated that zirconia oxyfluoride at the surface may react with organosilane to give chemical attachment to resin systems [18].

The purpose of the present study was to develop and evaluate etching procedures of zirconia with two different relatively low-melting fluoride substances applied as powders and aqueous slurries or pastes. The latter is to make it possible to apply the etchant on curved surfaces. The intension of etching was to create an irregular zirconia surface that facilitates for interlocking of resin and resin cement without subsurface damage. Based on the dissolution of ZrO₂ in molten KOH with the formation of zirconates and the affinity of fluoride to Zr⁴⁺, the melting of the relatively low-melting potassium hydrogen difluoride (KHF₂) and ammonium hydrogen difluoride (NH₄HF₂) were chosen as etching agents [19]. Another intention was also to investigate the influence of different surface treatment methods of the melt-etching procedure with these two compounds compared with sandblasting on simple shear bond strength. Scanning electron microscopy (SEM) and X-ray diffraction analysis were used to characterize structure, phases and phase transformations at the surface of the differently treated zirconia samples. Fourier transform infrared (FTIR)

spectroscopy was used to characterize possible reaction products from the etching process.

Materials and methods

Specimen preparation

Hot isostatic pressed (HIP) Y-TZP discs of 13 mm diameter and 1.25 mm thickness were received from Denzir Production AB (CAD Esthetic AB, Skellefteå, Sweden). They were milled from blocks, stated to be sintered at 1500 °C, 2000 bar (200 MPa), 4 d. Y-TZP rods of 5 mm diameter and 3.5 mm thickness were milled from Lava Multi XL blocks (3 M, St. Paul, MN). The rods were sintered at 1500 °C for 2 h in a high-temperature-sintering furnace (Zirkonofen 700 vacuum, Zirkonzahn, Gais, Italy). Each zirconia specimen was ground at a 20-µm diamond disc and polished with 15, 6 and 1 µm DP-spray P (Struers, Copenhagen, Denmark) respectively. Distilled water was used as a coolant during polishing the specimens.

The specimens were steam cleaned with Steam Cleaner X3 (Armann Girrbaach, Koblach, Austria), ultrasonically rinsed in distilled water and in ethanol for 15 min each by Finn Sonic m03/m ultrasonic bath (Lahti, Finland) and finally air-dried before surface treatment. The polished, cleaned zirconia discs and rods were randomly divided into 10 groups (10 samples in each group) and subjected to different surface treatments. Two groups were sandblasted (SB), four were etched with potassium hydrogen difluoride, KHF₂ (EK) (Fluka Analytical, Sigma-Aldrich, St. Louis, MO) and four with ammonium hydrogen difluoride, NH₄HF₂ (EA) (Fluka, Sigma-Aldrich, Buchs, Switzerland), respectively. Both etchants were applied as powder (.P) and water-based slurry (.S). One of each treatment groups were silanized (...S), the other were used unsilanized (...U). 10 specimens were fabricated for each group (*n* = 10). The groups are listed in Table 1.

Table 1. Groups listed with abbreviation and surface treatment procedure.

Abbreviation	Roughening treatment	Surface behavior
SBU	Sandblasting, 110 µm alumina	unsilanized
SBS	Sandblasting, 110 µm alumina	silanized
EKPU	Etched, K[FHF] powder	unsilanized
EKPS	Etched, K[FHF] powder	silanized
EAPU	Etched, NH ₄ [FHF] powder	unsilanized
EAPS	Etched, NH ₄ [FHF] powder	silanized
EKSU	Etched, K[FHF] slurry	unsilanized
EKSS	Etched, K[FHF] slurry	silanized
EASU	Etched, NH ₄ [FHF] slurry	unsilanized
EASS	Etched, NH ₄ [FHF] slurry	silanized

Sandblasting

Both disc and rod specimens were sandblasted with 110 μm alumina particles at one surface with a pressure of 2 bar in 5 s for the rod surfaces and 15 s for the discs. Sandblasted specimens were steam cleaned and rinsed in ultrasonic bath as well (15 min). One group was silanized (SBS) and one group was tested unsilanized (SBU). The silanized sandblasted group is considered as a control group.

Etching

Melting of the fluoride compound KHF_2 on ground and polished Y-TZP for 10 min gave a rough etched surface. The KHF_2 etchant with a melting point of 239 °C [20] is a particular compound with symmetrical hydrogen bonds in the linear and symmetrical $[\text{F}\cdots\text{H}\cdots\text{F}]^-$ ion [21]. An effective etchant is also a melt of the unstable, relatively low melting NH_4HF_2 with a melting point of 125 °C [20], also with symmetrical hydrogen bonds. These are melt/solid-state reactions with diffusion of fluoride species to the zirconia surface and diffusion of reaction products from the zirconia surface into the melt with partly precipitation at the surface. A schematic view of etching process is shown in Figure 1.

Crystals of KHF_2 were ground to fine powder in an agate mortar and the powder was spread on one flat surface of the zirconia discs and rods. The same procedure was also carried out using powder of NH_4HF_2 . The specimens with KHF_2 powder were placed on a metal plate and heated in a preheated furnace (Accu-therm II 2000, Jelenko, Armonk, NY) at a temperature of 280 °C, and the specimens with NH_4HF_2 at 170 °C, both for 10 min.

A small quantity of the powder was mixed with distilled water to viscous slurries (4.0 mg/ml for KHF_2 and 4.2 mg/ml for NH_4HF_2) and spread on one flat surface of zirconia discs and rods. These specimens were heated in the same way and at the same temperature as for the specimens covered with the powder.

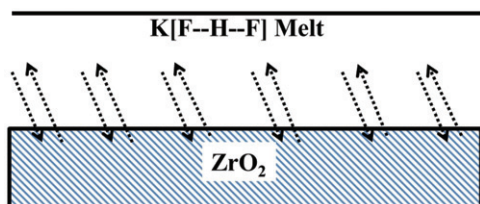


Figure 1. Schematic view of etching process. Diffusion of active etching agents in the melt and to the solid zirconia surface with simultaneous diffusion of etching products, fluorozirconates, from the zirconia surface and into the melt.

During the time in the furnace and after water evaporation, the fluoride compounds appeared melted. After 10 min, the plate with the specimens was removed from the oven and bench-cooled.

Etched specimens were steam cleaned, ultrasonically rinsed in water (15 min) and dried in air before silanization.

X-ray diffraction

Six zirconia disc specimens were polished and sintered at 1500 °C for 2 h in a high-temperature-sintering furnace to ensure that the structure was according to the as-sintered state. One specimen was sandblasted with 110- μm alumina particles at 2 bars. Four specimens were etched with KHF_2 and NH_4HF_2 with powder and slurry, respectively. Specimens of different groups after surface treatment and untreated polished specimens were subjected to X-ray diffraction (XRD) to determine the phases present and whether there was a phase transformation due to sandblasting or difluoride etching. The phase distribution and crystallinity of the specimens were characterized using a Bruker D8 Discover diffractometer in Bragg-Brentano geometry with $\text{CuK}\alpha 1$ radiation selected by a Ge (111) monochromator with LynxEye detector (Bruker AXS GmbH, Karlsruhe, Germany)) at the Norwegian National Center for XRD and scattering (RECX). Data were collected with a step size of 0.02° and a count time of 0.7 s/step over a 2θ range of 20–120°. The analysis of XRD patterns was performed by the use of Rietveld method [22,23]. Phases were identified using the PDF-2 database in Bruker EVA software and Rietveld analysis was carried out using TOPAS-5 [24]. Crystallite sizes were determined by the Double Voigt approach [25], based on the sample column height from peak integral breadth (Lvol-IB method in TOPAS). A March-Dollase preferred orientation correction in the (1 – 1 – 1) direction was applied to the monoclinic phase. Atomic positions were not refined for any of the phases. The background was fitted with a 6-term Chebyshev polynomial function.

FT-IR measurements

In order to understand the chemical composition of the etched surface product, FT-IR (Fourier transform infrared spectrometry) measurements were carried out. The etched surface products derived from the KHF_2 etching were isolated from a resulting aqueous dispersion. The melted and precipitated fluoride products were thoroughly washed off the etched surfaces with water and ultrasonically rinsed in distilled water

(1–2 min), followed by centrifugation in Heraeus Multifuge X3 FR (Thermo Scientific, Langenbold, Germany) and separated for FT-IR analysis.

The remaining powder was dried and ground with an agate mortar and pestle. Few drops of mineral oil (Nujol, Sigma Aldrich, St. Louis, MO) was added to the powder and mixed well. The liquid suspension was introduced into an IR liquid cell (0.025 mm thick CsI windows, Perkin Elmer, Norfolk, CT) with a syringe. IR spectra were recorded in nitrogen atmosphere in the region $4000\text{--}200\text{ cm}^{-1}$ at a resolution of 2 cm^{-1} by carrying out 25 scans on an FT-IR spectrometer (Varian 670-IR, Agilent Technologies, Santa Clara, CA). In addition, FT-IR spectra of Nujol and the reference potassium hexafluorozirconate, $\text{K}_2[\text{ZrF}_6]$ (Sigma-Aldrich, St. Louis, MO) were examined at room temperature. From the FT-IR spectra of the etched surface product and $\text{K}_2[\text{ZrF}_6]$, the Nujol spectrum was subtracted.

Also the remnants from the etching with NH_4HF_2 were washed and attempted separated. However, all the remnants were dissolved in the water and were not analyzed.

Silanization and cementation

Silanization was carried on the surfaces of the zirconia discs and rods with freshly mixed solutions of the monosilane (3-methacryloyloxypropyltrimethoxysilane) in ethanol and acetic acid also in ethanol to have an effective silane being capable of wetting the etched surfaces, Bis-Silane (Bisco, Schaumburg, IL).

First, a layer of Bis-Silane was applied and the surfaces were dried using compressed air. Next step was coating with a layer of HEMA-free resin (Porcelain Bonding Resin, Bisco, IL). Thereafter, they were joined together with Duo-Link composite luting cement. Zirconia disc and rod was pressed together manually, followed by pressing together by applying a force of 50 N and the resin systems were polymerized using the light source Bluephase (Ivoclar-Vivadent, Amhurst, NY) from four directions for 20 s each. The specimens were stored at 37°C for 24 h. The material combination of the etched zirconia discs and rods with all bonding layers is schematically shown in Figure 2.

Bond strength measurements

The bond strength between zirconia discs and rods was determined by a shear bond test in accordance with Test 7.7 Bond strength in ISO 10477:2004 [26] using a universal mechanical test machine (Lloyds

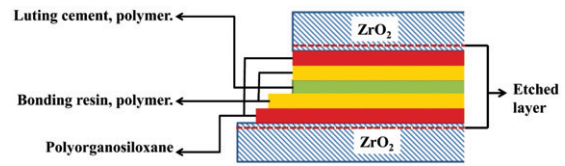


Figure 2. Schematic illustration of combination of materials (zirconia bonded to zirconia ceramic).

Table 2. Mean shear bond strength values of all groups tested along with the standard deviation.

Specimen group	Shear bond strength ($n = 10$) (MPa)	Standard deviation (MPa)
SBU	5.4 ^a	1.7
SBS	26.2 ^b	7.4
EKPU	34.7 ^b	8.3
EKPS	31.2 ^b	7.5
EAPU	45.6 ^b	11.3
EAPS	31.9 ^b	11.1
EKSU	38.8 ^b	7.9
EKSS	42.7 ^b	12.7
EASU	37.3 ^b	11.5
EASS	40.3 ^b	10.1

Superscripts indicate statistically indistinguishable groups as found by *F*-test (a/b , $p < 0.05$).

LRX 9439, Lloyds Instruments Ltd, Fareham, UK) at a crosshead speed of 1 mm/min. Bond strength was calculated by Nexigen MT v4.5 software system (Ametek, Largo, FL).

Statistics

Means and standard deviations of bond strength were calculated for each group and tested statistically using *F*-test ($p < 0.05$).

Scanning electron microscopy

The fracture surfaces were examined in two randomly selected specimens from each group after shear bond testing. The specimens were sputter-coated with a layer of gold-palladium and analyzed under a SEM (PHILIPS XL-30 ESEM, Eindhoven, Netherlands) for surface topography analysis.

Results

Shear bond testing

The mean shear bond strength values of all groups are presented in Table 2 with standard deviations. Sandblasted, unsilanized specimens displayed lowest bond strength, indicating low chemical attachment between Y-TZP surfaces and resin cement. Both the silanized, sandblasted group and all difluoride-etched groups had significantly higher bond strength

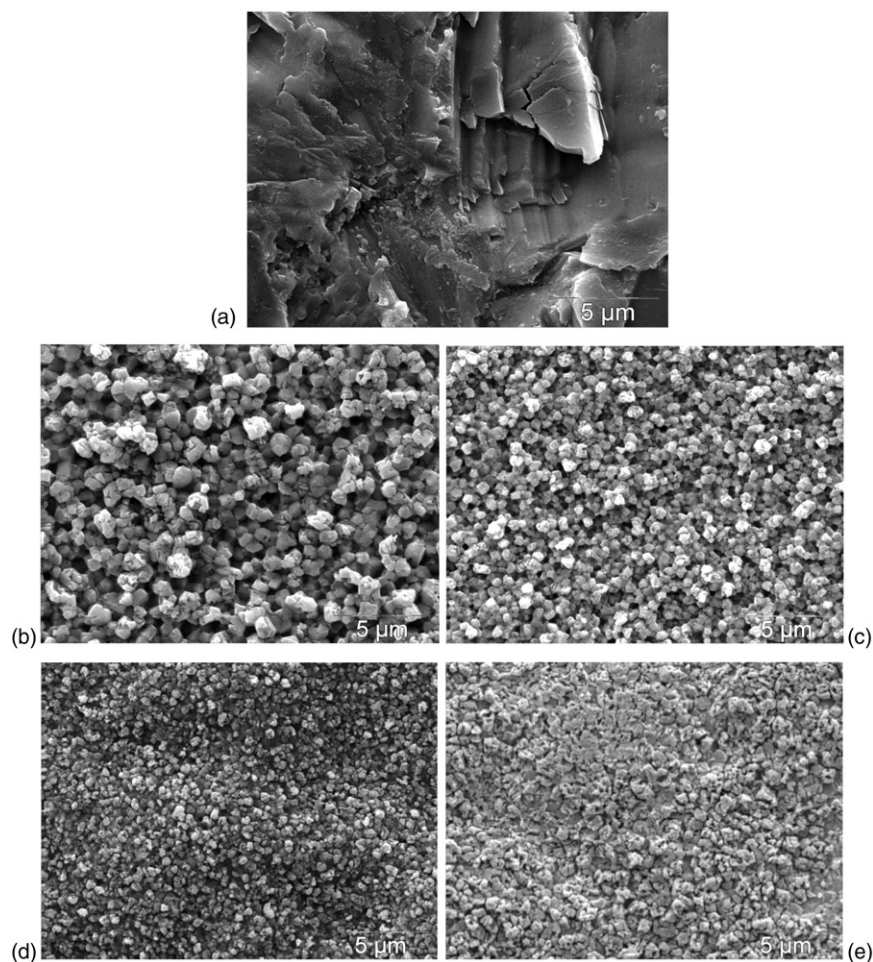


Figure 3. SEM images of the zirconia disc specimens (reference) after different surface treatments (a) Sandblasted; (b) K[FHF] powder, etched; (c) K[FHF] slurry, etched; (d) $\text{NH}_4[\text{FHF}]$ powder etched; (e) $\text{NH}_4[\text{FHF}]$ slurry etched.

than the unsilanized, sandblasted group (F -test, $p < 0.05$).

Scanning electron microscopy

Scanning electron microscopy (SEM) images of the sandblasted and difluoride etched zirconia disc specimens are presented in Figure 3(a–e). Sandblasted specimen (Figure 3(a)) having different surface morphology than those of etched specimens (Figure 3(b–e)). With 110 μm sandblasting, large grooves and voids were observed on the surface of zirconia ceramic. Etched specimens show a rough surface with exposed homogeneous grains of an average size of 0.3 μm . Etching with the NH_4HF_2 compound gave a similar surface as those etched with KHF_2 .

Scanning electron microscopy of fracture surface

SEM images of the different groups of specimens after shear bond testing are shown in Figure 4(a–c) and show the etched surface of zirconia with grains

0.3–0.5 μm in size, which resulted in an inter-granular ‘porosity’ at the surface allowing the silane primer to penetrate and interlock or hook between the grains. Representative images of the fracture surfaces of zirconia disc and rod specimens after shear bond testing are shown in Figure 5(a–d). Specimens with strong bond strength showed a combination of adhesive with bonding agent partly remaining on the zirconia surface.

X-ray diffraction

The Rietveld refinement plots for Y-TZP specimens after different surface treatments are presented in Figure 6(a–d). From Figure 6(a), it was evident that no peaks corresponding to monoclinic ZrO_2 phase were observed in the polished specimen. It should be noted that the cubic and tetragonal structures of zirconia are very similar ($a = 0.5124 \text{ nm}$ for cubic, and $a = 0.5094 \text{ nm}$ and $c = 0.5177 \text{ nm}$ for tetragonal structures), so many of their diffraction peaks overlap in the $2\theta < 70^\circ$ range. At higher 2θ Bragg angles,

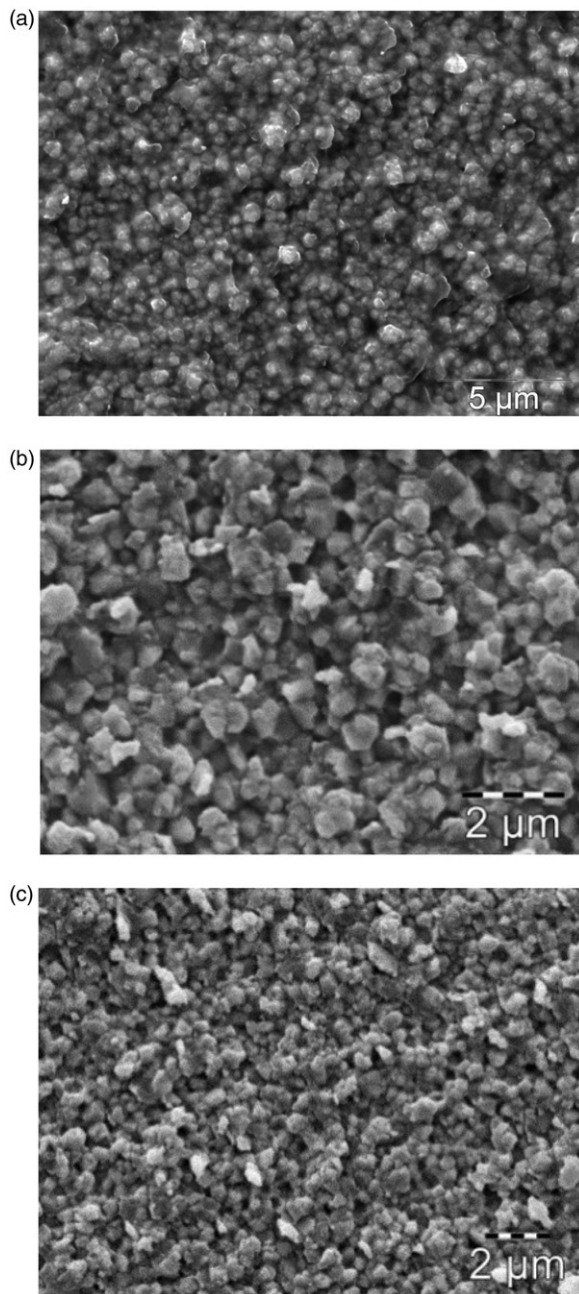


Figure 4. SEM images of the zirconia disc specimens after shear bond measurements (a) EKPS (b) EKPU and (c) EKSU.

however, the cubic phase exhibits single peaks at all reflection positions, whereas the tetragonal peaks split into two [27]. XRD patterns of all specimens show two well-separated reflection lines at $2\theta = 73$ and 74° .

XRD patterns of the etched specimens showed a very sharp low-intensity peak at $2\theta = 28^\circ$, which corresponds to the monoclinic ZrO_2 phase. On the other hand, XRD pattern of the sandblasted specimen showed a broad monoclinic peak at $2\theta = 28^\circ$. Weak peaks were observed at $2\theta = 31$ and 34° which probably are due to monoclinic ZrO_2 phase.

The quantitative analysis and crystallite size results for the studied specimens are given in Table 3, along with the Rwp factors for the fits. Cubic (ICSD 89429) tetragonal (ICSD 23928) and monoclinic (ICSD 26488) ZrO_2 phases were used for phase quantification and crystallite size analysis. As mentioned earlier, no monoclinic phase was detected after polishing the specimens. Zirconia surfaces etched with difluorides induced limited, $\sim 1\text{--}2\text{ wt\%}$ tetragonal-to-monoclinic phase transformation. The highest fraction of monoclinic phase, $\sim 15\text{ wt\%}$, was found after sandblasting the zirconia surfaces. Of note are the increase of $\sim 15\text{ wt\%}$ of the cubic phase from 14 wt\% to 29 wt\% after sandblasting and the reduction of the tetragonal phase to $\sim 56\text{ wt\%}$.

FT-IR measurements

From FT-IR measurements, the etched surface product was assumed to be $\text{K}_2[\text{ZrF}_6]$ and it was indicated by FT-IR spectra with absorptions at $506, 502, 491, 484, 472$ and 468 cm^{-1} in the region $460\text{--}510\text{ cm}^{-1}$ as shown in Figure 7(a,b). FT-IR spectra of etched surface product in the region $500\text{--}205\text{ cm}^{-1}$ was presented in Figure 8(a), which is close to identical to that of commercially available $\text{K}_2[\text{ZrF}_6]$ (Figure 8(b)).

Discussion

Good wetting is crucial for obtaining adhesion of restorations with resins. Further a good and durable bonding, both micromechanical retention and chemical adhesion is required [28].

The results of the shear bond tests of zirconia rods bonded to zirconia discs showed good adhesion for all combinations of hydrogen difluoride-etched surfaces with and without silane treatment (Table 2). The state of the adhesion between a zirconia rod and a zirconia disc corresponds to a cementation of a crown or frame attached to an abutment (implant or dentin abutment). The adherends are not subject to contraction or strain. Such phenomena only take place in the adhesive layer.

The shear bond data show an improvement in the shear bond strength values by difluoride etching. Highest shear bond strength values (42.7 ± 12.7 and $45.6 \pm 11.3\text{ MPa}$) among the investigated groups were obtained by KHF_2 and NH_4HF_2 etching. This indicates difluoride etching created surface roughness that increased the bond strength.

Low bond strength was obtained with sandblasted zirconia without silane application ($5.4 \pm 1.7\text{ MPa}$). Mean shear bond strength values for silanized,

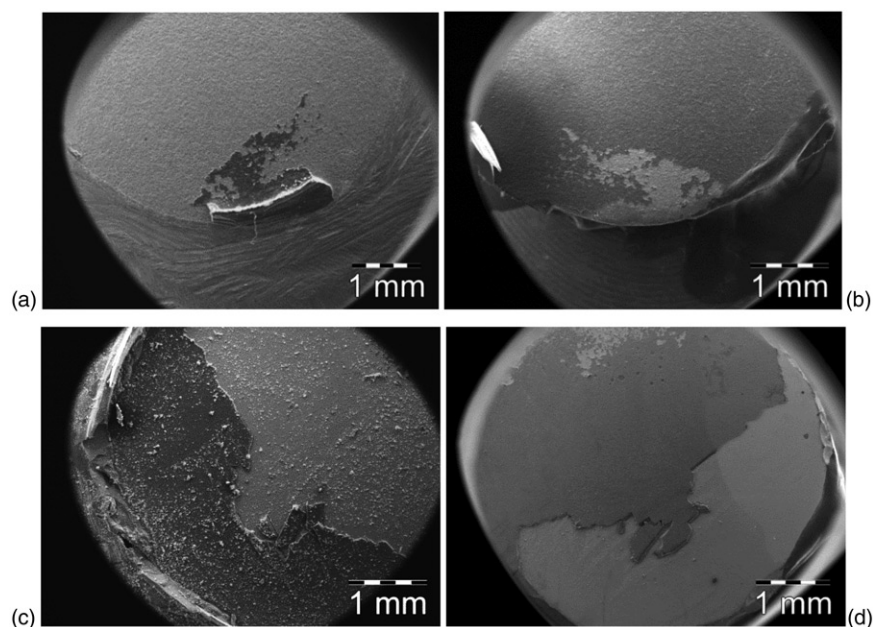


Figure 5. SEM images of the fracture surfaces of zirconia disc and rod specimens after shear bond testing measurements. Light areas are thin layers and darker areas are thicker layers of bonding resin cement. (a) SBS zirconia disc, contact area at the upper part; (b) SBS zirconia rod, contact area at the upper part; (c) EASS zirconia disc, contact area; (d) EASS zirconia rod, contact area.

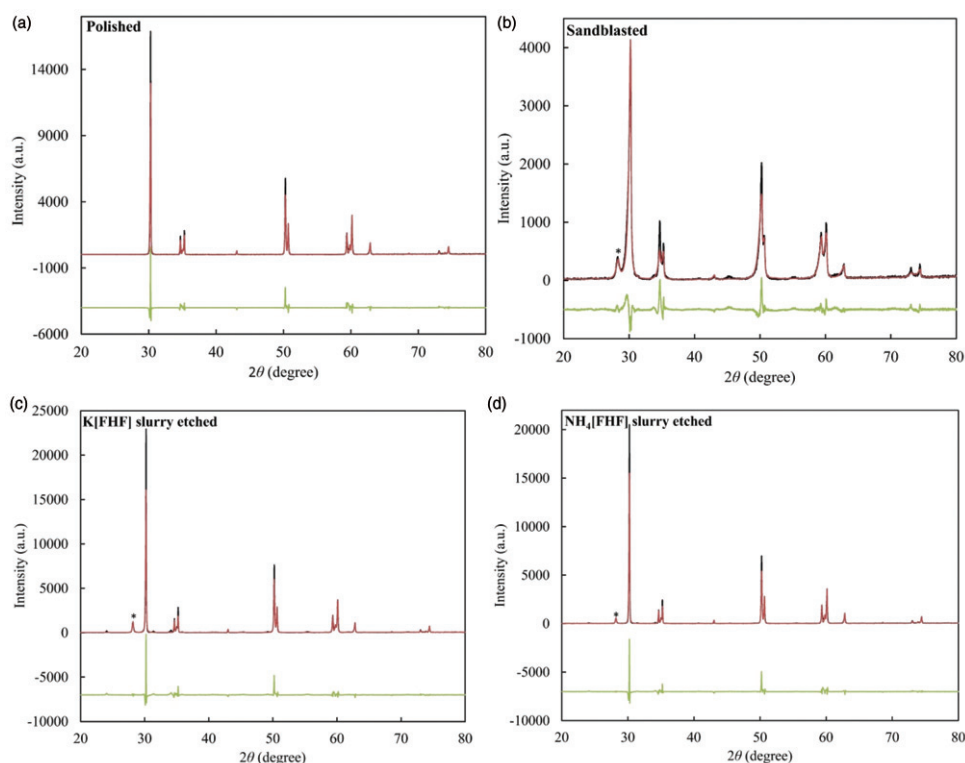


Figure 6. Rietveld fit to XRD data for Y-TZP specimens after different surface treatments. (a) Polished; (b) Sandblasted; (c) K[FHF] slurry etched; (d) $\text{NH}_4[\text{FHF}]$ slurry etched. Upper plots showing observed and calculated intensities, lower plot shows the difference for the samples. *Monoclinic peak.

sandblasted specimens (26.2 ± 7.4 MPa) were significantly higher. This indicates that silanization involves an important contribution in adhesion between sandblasted zirconia surfaces and resin cement in

facilitating wetting of the zirconia surfaces. The freshly mixed solution of the 3-methacryloyloxypropyltrimethoxysilane and acetic acid in ethanol will reduce formation of organosiloxane oligomers at

Table 3. Results of quantitative and crystallite size analysis by the Rietveld method.

Sample	Weight (%)			Crystallite Size (nm)			Rwp
	Monoclinic	Tetragonal	Cubic	Monoclinic	Tetragonal	Cubic	
POL	0	86	14	—	304.2	175.6	24.1
EKPU	2	79	19	49.5 ^a	225.6	50.9	24.3
EKSU	2	80	18	48.5 ^a	231.6	55.5	24.7
EAPU	1	83	15	56.5 ^a	267.4	112.9	23.9
EASU	1	83	16	55.0 ^a	262.9	111.7	24.0
SBU	15	56	29	14.0	61.6	10.6	17.6

Approximate uncertainty in weight percentages = $\pm 3\%$, crystallite sizes ± 10 nm.

Rwp is a reliability factor (weight profile factor).

EKPU: K[FHF] powder etched; EKSU: K[FHF] slurry etched; EAPU: NH₄[FHF] powder etched; EASU: NH₄[FHF] slurry etched; POL: polished; SBU: sandblasted (110 μ m 2 bar).

^aThese crystallite size values are not much reliable due to the low weight fraction of the monoclinic phase present and they are calculated from a single tiny peak.

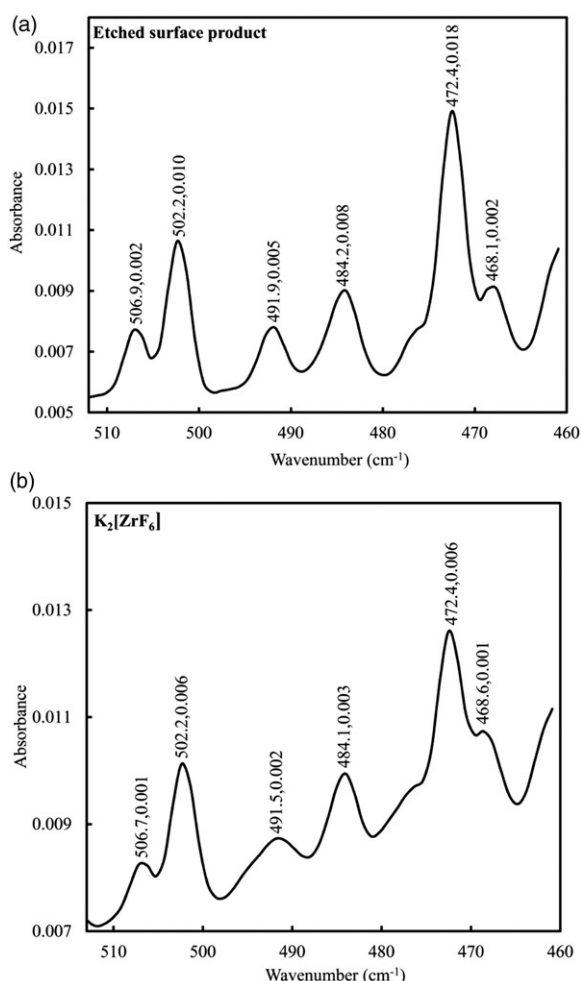


Figure 7. FT-IR spectra of (a) etched surface product and (b) K₂[ZrF₆] in the region 510–460 cm⁻¹. The figures on the absorption peaks represent wavenumbers and peak areas.

application and have a lesser tendency for wetting the zirconia surface and probably result in a reduced formation of a stable polysiloxane film. With organosiloxane oligomers, the tendency for chemical reaction with the formation of initial intermolecular bonding such as hydrogen bonds with zirconia is also reduced [29].

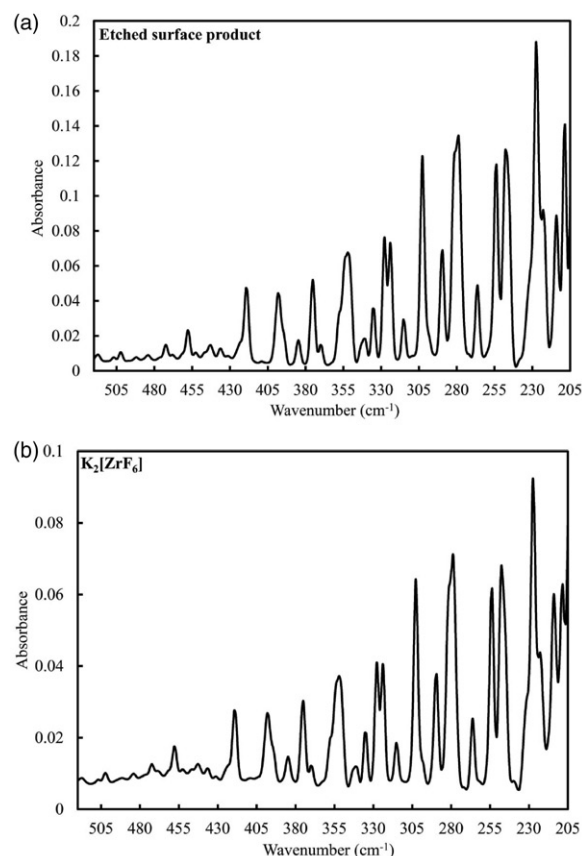


Figure 8. FT-IR spectra for (a) etched surface product and (b) K₂[ZrF₆] in the region 500–200 cm⁻¹.

By sandblasting of zirconia, high surface energy and wettability are normally achieved [30]. It must therefore be assumed that the zirconia surfaces were inactivated by the steamed water treatment and the ultrasonic water bath leaving hydrated surfaces and adsorbed water.

Sandblasted zirconia samples that were silanized exhibited good bonding. However, uncertainty has been expressed that the roughening process applied might introduce flaws, cracks and grain pullouts as well as induce phase transformation of the zirconia,

which with time will reduce the strength of the ceramic [1,15,31]. In particular, the formation of cracks and grooves (Figure 3(a)) in the surface together with volume expansion due to transformation from cubic to tetragonal to monoclinic structure may induce stress concentrations [2]. Thus, airborne alumina particles and the accompanying surface defects may degrade the long-term performance in clinical use [32].

Table 3 reveals the changes between the cubic, tetragonal and monoclinic forms at the surface of Y-TZP before and after sandblasting. After sandblasting, the quantity of cubic form is twice that in the as-sintered material and the tetragonal form is also partly transformed to a volume fraction of 15% monoclinic form.

The formation of cubic zirconia is assumed to originate from the high-energy impact of alumina particles on the zirconia surface leading to very high local temperatures (tetragonal \rightarrow cubic; phase transition temperature: 2370 °C [pure ZrO_2]). The amount of energy released is dependent on mass and velocity of the particles and it has been calculated to give temperatures of several thousand K at the points of impact [33]. In addition, the high-energy alumina particle blasting causes fracture of the grains and zirconia crystals with formation of smaller crystallites at the surface (Table 3).

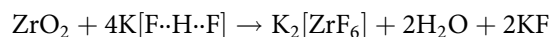
The shear bond strength between zirconia surfaces and the attached resin systems was slightly enhanced for the sample groups that were exposed to the melting difluorides KHF_2 and NH_4HF_2 compared to the silanized, sandblasted group. The slurries of the hydrogen difluorides have been used to achieve good contact with zirconia when applied for crowns and abutments having curved surfaces. Melt etching of zirconia with the fluorides created a rough surface of exposed zirconia grains with deep grooves. Moreover, specimens etched with difluorides appear to have similar morphology to that of specimens etched with hydrofluoric acid [7] as shown in the SEM-images in Figures 3(b–e) and 4(a–c).

This facilitates the micromechanical retention of resin and luting cement. The silane solution and the uncured liquid resin can penetrate into the irregularities in the zirconia surface. A secondary effect of the etching together with the steam and aqueous ultrasonic treatment is to cleanse the ceramic surface by removing unwanted oxides, debris and precipitates. It is anticipated that during treatment with the melted hydrogen difluorides the surface of zirconia is fluoridated, which after steam and ultrasonic water treatment, becomes hydrolyzed leaving active hydroxyl

sites. Hydroxylation of zirconia is indicated, similar to that described by Lohbauer et al [34] from the treatment of zirconia ceramics with a mixture of sulfuric acid and hydrogen peroxide (piranha solution). These hydroxyl groups are reactive with hydroxyl groups of silanols resulting from hydrolyzed 3-methacryloyloxypropyltrimethoxysilane. This reaction gives hydrogen bonds which, over time, may develop into covalent oxygen bonding between silicon of the organopolysiloxane and the zirconium atoms in the zirconia surface, giving even more stable bondings than hydrogen bonds alone.

The difluorides are hydrogen compounds with symmetric hydrogen bonds with linear anions, $\text{K}[\text{F}\cdots\text{H}\cdots\text{F}]$ and $\text{NH}_4[\text{F}\cdots\text{H}\cdots\text{F}]$. Based on these circumstances, KHF_2 is probably quite stable up to and above the melting point, whereas NH_4HF_2 decomposes during melting. During the laboratory work and in particular during heating in the oven, good ventilation is required due to released fumes and the toxicity of fluorine compounds and the aggressive nature of hydrofluoric acid [35].

The efficiency of the etching is based on dissolution of ZrO_2 in the molten $\text{K}[\text{F}\cdots\text{H}\cdots\text{F}]$ and the affinity of F^- for Zr^{4+} and the evaporation of water:



The substance denoted as $\text{K}_2[\text{ZrF}_6]$ may also have the Zr coordination number 8 and, as a result, have a more complex structural arrangement than other group IV hexafluorometallates [36–38]. The Zr atom in the lattice is surrounded by eight F atoms, four of which are bridging [39]. The Zr coordination polyhedra share edges and thus form infinite chains $[\text{ZrF}_6]_n^{2n-}$ [39]. According to calculations performed various numbers of vibrational frequencies for the monomeric, dimeric and polyhedral complexes with coordination numbers 6–8 of potassium fluoro-zirconate compounds have been reported [40]. However, the observed number of bands in the range 600–200 cm^{-1} in previous published experimental spectra is much smaller, probably due to overlap and coincidence [38,41]. Our experimental FT-IR spectra exhibit a larger number of well-defined IR bands within the wave number range 530–205 cm^{-1} . It is seen that the profile of the bands corresponding to asymmetric stretching vibrations of the terminal Zr–F bonds in the experimental IR spectrum of K_2ZrF_6 is complicated. Due to the complexity of the K_2ZrF_6 spectra, no interpretation has been attempted. Recently, Voit et al. [40] assigned the vibrational modes for different Zr based compounds theoretically. In general, theoretically calculated absolute values are not directly comparable with the

experimental data. However, one can use this qualitative picture to assign different vibrational modes present in the IR spectra. The Zr–F stretching modes (symmetric and asymmetric) are present above wavenumber 310 cm^{-1} and F–Zr–F bending modes are present between the wavenumbers 310 and 200 cm^{-1} . In order to understand the origin of the individual peaks, more detailed structural and spectroscopic studies are needed. However, it can be concluded that the substance denoted as $\text{K}_2[\text{ZrF}_6]$ was a mixture of potassium fluoro-zirconates, including both monomeric and polymeric anionic complexes.

Conclusions

Melting of the fluoride compounds KHF_2 or NH_4HF_2 on ground and polished Y-TZP gave a rough etched surface suitable for good and durable adhesion to a zirconia implant or dentin abutment.

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Disclosure statement

The authors report no conflicts of interest. The authors alone are responsible for the content and writing of this article.

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